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Customer Number

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Patent

Case No.: 53415US038

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named Inventor: HARDY, L. CHARLES

Application No.: 09/707269

Group Art Unit: 2829

Filed: November 6, 2000

Examiner: Caridad Everhart

Title: METHOD OF MODIFYING A WAFER SUITED FOR SEMICONDUCTOR  
FABRICATIONPETITION FOR EXTENSION OF TIME UNDER 37 CFR § 1.136(a)Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

## CERTIFICATE OF MAILING OR TRANSMISSION [37 CFR § 1.8(a)]

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- ☒ transmitted by facsimile on the date shown below to the United States Patent and Trademark Office at (703) 872-9306.

June 1, 2005

Date

Signed by: Kathleen M. Sandvig

Dear Sir:

Under the provisions of 37 CFR § 1.136(a), Applicant petitions to extend the period for filing a reply in the above-identified application. The requested extension and appropriate fee are as follows (check time period desired):

- ☒ 37 CFR § 1.17(a)(1) - Extension within first month
- ☐ 37 CFR § 1.17(a)(2) - Extension within second month
- ☐ 37 CFR § 1.17(a)(3) - Extension within third month
- ☐ 37 CFR § 1.17(a)(4) - Extension within fourth month
- ☐ 37 CFR § 1.17(a)(5) - Extension within fifth month

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Respectfully submitted,

June 1, 2005

Date

By: 

Daniel D. Biesterveld, Reg. No.: 45,898

Telephone No.: (651) 737-3193

Office of Intellectual Property Counsel  
3M Innovative Properties Company  
Facsimile No.: 651-736-3833

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Patent

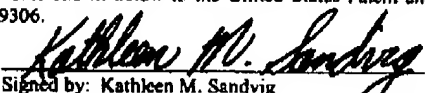
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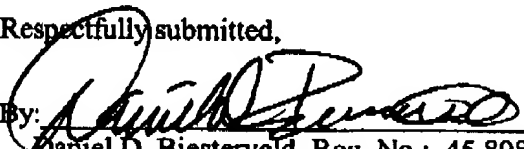
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